

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Davis, et al.	§	Case: 6716/ETCH/SILICON
	§	
Serial No.: 10/674,568	§	Filed: September 29, 2003
	§	
Examiner: Ram N. Kackar	§	Group Art Unit No. 1763
	§	
Confirmation No.: 3852	§	
	§	
Title: METHOD AND SYSTEM FOR	§	
MONITORING AN ETCH PROCESS	§	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

RESPONSE TO OFFICE ACTION DATED DECEMBER 28, 2007

In response to the Office Action dated December 28, 2007, having a shortened statutory period for response set to expire on March 28, 2008, please enter this response and reconsider the claims pending in the application for the reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.